

APPARATUS FOR MEASURING DEFORMING FUNCTION OF CELL

Patent Number: JP1196566
Publication date: 1989-08-08
Inventor(s): MASUDA SENICHI; others: 02
Applicant(s): ADVANCE CO LTD
Requested Patent: ☐ JP1196566
Application Number: JP19880019545 19880201
Priority Number(s):
IPC Classification: G01N33/49; G01N27/02
EC Classification:
Equivalents: JP2720161B2

Abstract

PURPOSE: To obtain an apparatus capable of well measuring the deforming function of a cell, by providing a means for allowing a cell to pass through a flow passage having a fine caliber and a means for measuring the electrical impedance of a cell-containing medium when the cell passes through said flow passage.

CONSTITUTION: The first electrolytic cell 2 and the second electrolytic cell 5 are provided on a substrate 1 having an electric insulating property so as to communicate with each other through a fine flow passage 6 having a diameter capable of permitting one cell to pass. The first and second electrodes 4, 8 are provided to the first and second electrolytic cells 2, 5 and connected to an AC voltage generating means 10 and an ammeter 11. After the electrolytic cells 2, 5 are filled with an electrolyte containing a cell C, the electrolyte is recirculated by a fluid pump 12. Since the cell C enters the fine flow passage 6 from the first electrolytic cell 2 according to the flow of the electrolyte and the impedance of the system during the passage through the fine flow passage 6 depends on the deforming function of the cell, by detecting the impedance of the system by an impedance operation means 13, the deforming function of the cell can be measured.

Data supplied from the esp@cenet database - I2